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Oquela By aperwor	K Reduction Act of 1995, 110 per	sons are required to res	Application Number	10/734,593
TRANSMITTAL			Filing Date	December 15, 2003
FORM			First Named Inventor	Srivatsa KUNDALGURKI
(to be used for all correspondence after initial filing)			Art Unit	2826
			Examiner Name	E. T. Pert
Total Number of Pages in This Submission		sion 7	Attorney Docket Numb	ber 543822003300
	EN	ICLOSURES	(Check all that ap	ply)
Fee Trans	mittal Form	Drawing(s) R	leplacement Sheet	After Allowance Communication to TC
Fee Attached		Licensing-related Papers		Appeal Communication to Board of Appeals and Interferences
X Amendme	ent/Reply	Petition		Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)
Afte	r Final	Petition to Convert to a Provisional Application		Proprietary Information
Affidavits/declaration(s)		Power of Attorney, Revocation Change of Correspondence Address		Status Letter
Extension of Time Request		Terminal Disclaimer		X Other Enclosure(s) (please Identify below):
Express Abandonment Request		Request for Refund		Return Receipt Postcard
Information Disclosure Statement		CD, Number of CD(s)		
Certified Copy of Priority Document(s)		Landscape Table on CD		
Reply to Missing Parts/ Incomplete Application		Remarks		· · · · · · · · · · · · · · · · · · ·
	ly to Missing Parts under CFR 1.52 or 1.53			
	SIGNATI	JRE OF APPLICA	NT, ATTORNEY, OF	R AGENT
Firm Name	MORRISON & FOERSTER LLP			
Signature	ale			
Printed name	Adam Keser			

Reg. No.

54,217

Date

August 26, 2006



Docket No. 543822003300 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Srivatsa KUNDALGURKI

Confirmation No. 1431

Application No. 10/734,593

Art Unit: 2826

Filed: December 15, 2003

Examiner: Evan T. Pert

For: METHOD FOR REMOVING A RESIST MASK

WITH HIGH SELECTIVITY TO A CARBON HARD MASK USED FOR SEMICONDUCTOR

STRUCTURING

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated May 26, 2005, please amend this application as follows.

Amendments to the Claims begin on Page 2.

Remarks begin on Page 4.